

FRAUNHOFER INSTITUTE FOR ORGANIC ELECTRONICS, ELECTRON BEAM AND PLASMA TECHNOLOGY FEP



coFlex[®] 600 ROLL-TO-ROLL PILOT SPUTTER ROLL COATER

Fraunhofer Institute for Organic Electronics, Electron Beam and Plasma Technology FEP

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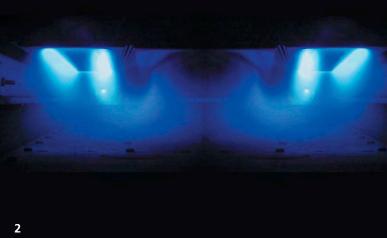
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The surface refinement of polymer films and other flexible substrates by applying thin coatings allows these materials to be used in a wide range of products. Vacuum based roll-to-roll plants allow coatings to be efficiently applied at favorable cost.

The *coFlex*® *600* vacuum web coating plant can be used to deposit optical, electrical, and decorative layers on substrates via sputtering techniques and magnetron PECVD processes. Line speed of up to 100 meters per minute can be achieved. Potential applications for the coated materials are numerous. Optical layer systems are, for example, used for UV mirrors and as infrared-reflecting heat protection layers. Electromagnetic decoupling layers (EMI layers) and transparent conducting layers are used for displays. Flexible solar cells require front and back contacts or transparent conducting layers which are applied to polymer films.

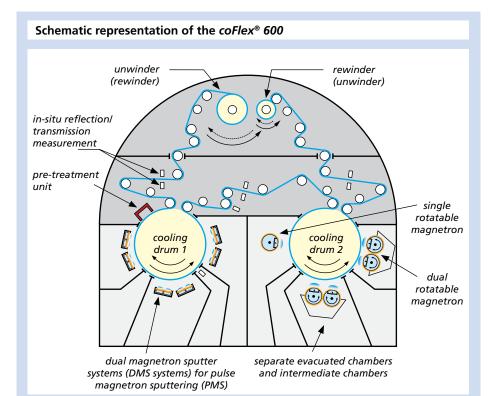
The *coFlex*[®] 600 has a pre-treatment unit, optical in-situ measuring units, and several coating chambers. Thus, at Fraunhofer FEP we have a complete system for the development and pilot production of multilayer systems under realistic production conditions at our disposal.





Technical specifications

600 mm
650 mm
7 200 μm
400 mm
0.1 100 m/min
 dual magnetron sputter systems (DMS systems)
 single magnetron sputter systems (SMS systems)
 rotatable magnetron
(in cooperation with VON ARDENNE GmbH)
• ion source
metals, TiO_2 , SiO_2 , Nb_2O_5 , ITO, ZAO, SnO_2 , HfO_2 ,
WO ₃ , TiN, Si ₃ N ₄ , ZrO ₂ ,
 optical transmission and reflection
 electrical resistance



Technology

pulse magnetron sputtering:

- dual magnetron sputtering
- unipolar magnetron sputtering
- DC sputtering
- magnetron PECVD
- in-line pretreatment

Our offer

- development of technologies for coating polymer films and other flexible materials and development of plasma pretreatment processes
- development of layer systems (optical, electrical, and decorative functional layers, barrier layers)
- development and testing of key components
- sample provision for testing and marketing purposes, and pilot production
- studies on the efficiency of coating processes

2 Pulse magnetron sputtering (PMS)



We focus on quality and the ISO 9001.

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¹ Coated roll of polymer film